



XA-9967
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Atsushi HIRAIWA et al.

Conf. No.: 7336

Appln. No.: 10/695,798

Group Art Unit: 2829

Filed: October 30, 2003

Examiner: C. Everhart

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICES

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AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to the commencement of continued examination,
please amend the above-identified patent application as
indicated below.

Amendments to the claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
the United States Postal Service with sufficient postage as first class
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1450, Alexandria, VA 22313-1450 on the date shown below.

10/10/2006

Date


Signature